



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/594,475

Group Art Unit:

1793

Filing Date:

September 28, 2006

Examiner:

M. MARCHESCHI

Applicant:

Yoshiharu OHTA et al.

Title:

SEMICONDUCTOR POLISHING COMPOSITION

Attorney Docket:

2691-000058/US

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 October 20, 2008

Mail Stop AF

AMENDMENT UNDER 37 C.F.R. §1.114

Sir:

In response to the Office Action mailed May 19, 2008, and upon entry of the Request for Continued Examination, the shortened statutory period for reply being extended to October 19, 2008, by the attached Extension of Time, the following amendments and remarks are respectfully submitted.

Amendments to the Claims begin on page 2.

Remarks begin on page 4 of this Amendment.

1 2 2 2 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4 4	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	4	-	20	=	0
Independent	1	-	3	=	0